

List of ScanWave™ or sMIM publications etc.:

1. Johnston, S. R., Ma, E. Y., & Shen, Z. X. (2018). Optically coupled methods for microwave impedance microscopy. *Review of Scientific Instruments*. <https://doi.org/10.1063/1.5011391>
2. Johnston, S. R., Yang, Y., Cui, Y. T., Ma, E. Y., Kämpfe, T., Eng, L. M., ... Shen, Z. X. (2017). Measurement of surface acoustic wave resonances in ferroelectric domains by microwave microscopy. *Journal of Applied Physics*. <https://doi.org/10.1063/1.4997474>
3. Cui, Y. T., Ma, E. Y., & Shen, Z. X. (2016). Quartz tuning fork based microwave impedance microscopy. *Review of Scientific Instruments*. <https://doi.org/10.1063/1.4954156>
4. Wei, Z., Cui, Y. T., Ma, E. Y., Johnston, S., Yang, Y., Chen, R., ... Chen, X. (2016). Quantitative theory for probe-sample interaction with inhomogeneous perturbation in near-field scanning microwave microscopy. *IEEE Transactions on Microwave Theory and Techniques*. <https://doi.org/10.1109/TMTT.2016.2537801>
5. Lai, K., Nakamura, M., Kundhikanjana, W., Kawasaki, M., Tokura, Y., Kelly, M. A., & Shen, Z.-X. (2010). Microwave imaging of mesoscopic percolating network in a manganite thin film. *ArXiv.Org, e-Print Archive, Condensed Matter*.
6. Ma, E. Y., Bryant, B., Tokunaga, Y., Aepli, G., Tokura, Y., & Shen, Z. X. (2015). Charge-order domain walls with enhanced conductivity in a layered manganite. *Nature Communications*, 6(May), 1–6. <https://doi.org/10.1038/ncomms8595>
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10. Manganites, R., Wu, X., Petralanda, U., Zheng, L., Ren, Y., Hu, R., & Cheong, S. (2017). Low-energy Structural Dynamics of Ferroelectric Domain Walls in Hexagonal I. *ArXiv:1702.06205*, (May), 1–9.
11. Johnston, S. R., Ma, E. Y., & Shen, Z. X. (2018). Optically coupled methods for microwave impedance microscopy. *Review of Scientific Instruments*. <https://doi.org/10.1063/1.5011391>
12. Lai, K., Peng, H., Kundhikanjana, W., Schoen, D. T., Xie, C., Meister, S., ... Shen, Z. X. (2009). Nanoscale electronic inhomogeneity in In₂Se₃nanoribbons revealed by microwave impedance microscopy. *Nano Letters*, 9(3), 1265–1269. <https://doi.org/10.1021/nl900222j>

13. Lai, K., Kundhikanjana, W., Peng, H., Cui, Y., Kelly, M. A., & Shen, Z. X. (2009). Tapping mode microwave impedance microscopy. *Review of Scientific Instruments*, 80(4). <https://doi.org/10.1063/1.3123406>
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17. Manganites, R., Wu, X., Petralanda, U., Zheng, L., Ren, Y., Hu, R., & Cheong, S. (2017). Low-energy Structural Dynamics of Ferroelectric Domain Walls in Hexagonal I. *Science Advances*, 3(May), 1–9.
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19. Wu, D., Li, X., Luan, L., Wu, X., Li, W., Yogeesh, M. N., ... Lai, K. (2016). Uncovering edge states and electrical inhomogeneity in MoS₂ field-effect transistors. *Proceedings of the National Academy of Sciences*, 113(31), 201605982. <https://doi.org/10.1073/pnas.1605982113>
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